Electrochemical capacitors are charge-storage devices which possess higher power density/longer cycle life than batteries\(^1\)\(^2\) and higher energy density than conventional capacitors.\(^3\) Their applications include hybrid power sources, backup power sources, starting power for fuel cells, and burst-power generation in electronic devices.\(^4\) Electrochemical capacitors are classified into two types, electric double layer capacitors (EDLC) and pseudo-capacitors, according to the energy-storage mechanisms. The capacitance of an EDLC arises from the separation of charge at the interface between the electrode and the electrolyte. However, pseudo-capacitance arises from redox reactions of electroactive materials with several oxidation states.\(^1\)\(^3\)\(^4\)\(^5\)\(^6\)

Carbon nanotubes (CNTs) have high accessible surface areas (nanometer size, hollow structure, and a low ratio of micropores), low resistance, and high stability. These properties make them potentially suitable for fabrication of electrodes in electrochemical capacitors.\(^3\)\(^4\)\(^6\)

The most effective catalysts for the production of CNTs by catalytic chemical vapor deposition are known to be transition metals, such as iron (Fe), cobalt (Co), and nickel (Ni). The packing densities of CNTs grown on Fe, Co, and Ni catalysts are \(4 \times 10^9\), \(4 \times 10^9\), and \(2 \times 10^9\) cm\(^{-2}\), respectively due to the easy agglomeration of the small sized Ni particles compared with Fe or Co particles.\(^7\) In order to form catalytic nanoparticles and reduce oxide to metal from the catalytic surface, the catalytic film was pretreated with a RF (radio frequency) hydrogen-plasma.\(^8\)\(^9\) In this study a Co catalyst was pretreated with RF hydrogen-plasma.

After the deposited Ni (catalyst) film was annealed at 850°C in hydrogen environment and then pretreated in various gas environments (N\(_2\), H\(_2\), N\(_2\) + H\(_2\) or NH\(_3\)), vertically aligned CNTs were grown in bamboo structure by thermal chemical vapor deposition (CVD) of acetylene in an NH\(_3\) environment at 850°C with the NH\(_3\) pre-treatment.\(^10\) After the deposited Co (catalyst) film was annealed at 800°C in hydrogen environment, vertically aligned CNTs were grown by thermal CVD of acetylene (2.4 to 16.7 vol%) in NH\(_3\) environment at 950°C without the NH\(_3\) pre-treatment.\(^11\) At atmospheric pressure, Co was used as a catalyst for thermal CVD of vertically aligned CNTs which were controlled by the flow rate of NH\(_3\) to C\(_2\)H\(_2\).\(^12\)

The objectives of this research were to identify effects of Co pretreated with H\(_2\) plasma, growing CNT with/without H\(_2\), and CNT growing temperatures as well as volume flow rates of NH\(_3\) on the CNT morphology and the specific capacitance as well as electrochemical stability of the prepared electrodes. Therefore, we could seek more vertical alignment as well as higher packing density CNTs grown in a simply thermal CVD process at ambient atmospheric pressure (reduce cost and scale up easily) and higher specific capacitance as well as more operational stability of the prepared electrodes.

2. Experimental

The silicon foil was used as a substrate due to its lower cost and smoother surface (compared with graphite). The silicon foil (\(1 \times 1 \times 0.05\) or \(1 \times 2 \times 0.05\) cm\(^3\)) was degreased ultrasonically in acetone and pure de-ionized water (Vol. 1:1) for 15 min and then oven-dried in air (50°C) to constant weight. Next, the Ti film (barrier layer and lower specific resistance) was deposited on the pretreated and grounded silicon foil substrate by RF magnetron sputtering from a 3-inch disk Ti target (purity: 99.995%, purchased from SCM, INC) in a vacuum chamber with a background pressure of \(7 \times 10^{-6}\) Torr. The distance between the target and the substrate was 10 cm. During deposition, the substrate was not intentionally heated. The sputtering time, sputtering pressure, sputtering power, and the volume flow rate of argon were maintained at 90 min, 20 mTorr, 60 W, and 25 cm\(^2\) min\(^{-1}\), respectively.

The Co (catalyst) particles were deposited on the Ti-coated silicon foil by RF magnetron sputtering from a 3-inch disk Co target (purity: 99.9%, purchased from SCM, INC) in a vacuum chamber with a background pressure of \(7 \times 10^{-6}\) Torr. The distance between the target and the substrate was 10 cm. The sputtering power, sputtering pressure, sputtering time, and the volume flow rate of argon were maintained at 50 W, 5 mTorr, 10 min, and 25 cm\(^2\) min\(^{-1}\), respectively. Next, the Co-Ti-coated silicon foil was weighed.
The Co-Ti-coated silicon foil was optionally placed into the reaction chamber (85 cm³) of the apparatus for RF plasma pretreatment (frequency: 13.56 MHz and maximum power: 1000 W). Then, the chamber was degassed to 7 × 10⁻⁶ Torr. Next, 50 cm³ min⁻¹ of hydrogen gas was introduced to the chamber to maintain its pressure at 5 Torr. The power, time, and temperature for plasma pretreatment were maintained at 50 W, 8 min, and 500°C, respectively. Subsequently, the pretreated Co-Ti-coated silicon foil was weighed.

CNTs were grown on the Co-Ti-coated silicon foil or pretreated Co-Ti-coated silicon foil using thermal CVD with a gas mixture of C₂H₂ (50 cm³ min⁻¹), Ar (100 cm³ min⁻¹), H₂ (11 cm³ min⁻¹) or without H₂ and different volume flow rates (40, 50, and 60 cm³ min⁻¹) of NH₃ for 20 min at different temperatures (700, 750, and 800°C). The CNTs grown on the Co-Ti-coated silicon foil were then weighed.

The CNTs grown on the pretreated Co-Ti-coated silicon foil were placed into the reaction chamber of the apparatus for plasma treatment. Then, the chamber was degassed to 7 × 10⁻⁶ Torr. Next, 60 cm³ min⁻¹ of nitrogen gas was introduced to the chamber to maintain its pressure at 1.3 Pa. Subsequently, the CNTs were modified by RF plasma at 150 W of power for 20 min of time and then the CNTs grown on the pretreated Co-Ti-coated silicon foil was weighed.

The electrochemical reversibility and stability of manganese oxide can be enhanced by adding an amount of cobalt (10.4–17.5 at%) oxide and the highest specific capacitance was obtained at 16.4 at% Co. Furthermore, zinc is cheaper than cobalt/manganese and the operational stability of zinc oxide is lower than that of cobalt oxide but higher that of manganese oxide. Therefore, after nitrogen-plasma treatment of the CNTs, the manganese-cobalt-zinc oxide film was deposited on the CNTs grown on the pretreated Co-Ti-coated silicon foil by RF magnetron sputtering from a 3-inch disk Mn-Co-Zn oxide (MnO₂/CoxZnO/NiO: Mn/Co/Zn = 67.2 at% / 16.4 at% / 16.4 at%, 99.9 wt%, melting point: about 817°C, purchased from SCM, INC, USA) target in a vacuum chamber with a background pressure of 7 × 10⁻⁶ Torr. The distance between the target and the substrate was 8 cm. The sputtering power, sputtering pressure, the substrate temperature, the volume flow rate of oxygen, and the volume flow rate of argon were maintained at 60 min, 20 mTorr, 60 W, 500°C, 5 cm³ min⁻¹ and 25 cm³ min⁻¹, respectively. Next, the pretreated Co-Ti-coated silicon foil with the manganese-cobalt-zinc oxide film was weighed.

Finally, a CNT or manganese-cobalt-zinc oxide/CNT electrode was prepared by the CNTs or manganese-cobalt-zinc oxide/CNTs grown on the Co-Ti-coated silicon foil being transferred to an aluminum current collector sheet (thickness: 0.001 cm) coated homogeneously with a slight amount of electrically conductive cement (silver, epoxy resin, and hardener) to prevent the silver paste and aluminum current collector from contacting the electrolyte. The CNT or manganese-cobalt-zinc oxide/CNT electrode was coated with epoxy resin except its surface with grown CNTs or deposited manganese-cobalt-zinc oxide.

Electrochemical measurements for the prepared electrodes were performed using an electrochemical analyzer (CH Instruments CHI 608B, USA). The three-electrode cell consisted of Ag/AgCl as the reference electrode, Pt as the counter electrode and the prepared CNT or manganese-cobalt-zinc oxide/CNT electrode as the working electrode. The electrolytes were degassed with purified nitrogen gas before voltammetric and nitrogen was passed over the solution during all the measurements. The solution temperature was maintained at 25°C by means of circulating water thermostat (HAAKE DC3 and K20, Germany). In our previous study, it found that the specific capacitance reached a maximum with H₂SO₄ by comparing with other electrolytes, therefore, the cyclic voltammetry (CV) in the range -0.5–1.5 V was taken in a 0.5 M aqueous electrolyte (LiCl, pH = 6.7) for the prepared manganese-cobalt-zinc oxide/CNT electrode since in our previous study, a maximum capacitance of 490 mF cm⁻² was obtained in 0.5 M NaCl and maximum capacitance of 556 mF cm⁻² was obtained in 0.5 M LiCl. A CV scan rate of 100 mV s⁻¹ was used in all measurements unless otherwise stated. Capacitance is normalized to 1 g of CNTs for the prepared CNT electrode or 1 g of manganese-cobalt-zinc oxide for the prepared manganese-cobalt-zinc oxide/CNT electrode unless otherwise stated.

Micrographs of Co (catalyst) pretreated as well as not pretreated with H₂ plasma, the packing density, diameter, length as well as cross-section micrographs of CNTs (Co not pretreated with H₂ plasma) grown at different conditions, and manganese-cobalt-zinc oxide deposited on the CNTs grown in 50 cm³ min⁻¹ NH₃ as well as without NH₃ were conducted by field emission scanning electron microscope (FE-SEM, JEOL JSM-6700F, Japan). In addition, the nanostructures of CNTs (Co not pretreated with H₂ plasma) grown without H₂ and in 50 cm³ min⁻¹ NH₃ as well as without NH₃ were examined through transmission electron microscope (TEM, JEOL JEM-2010, Japan). Furthermore, the intensity ratios of the C-C stretching mode to the disorder-induced mode of graphite structure for carbon products grown at different conditions were investigated by microscopes Raman spectrometer (inVia, Renishaw, England).

3. Results and Discussion

Figure 1 shows the effects of different CNT growing temperatures and different charge-discharge cycles on the specific capacitances of the CNT [grown in 50 cm³ min⁻¹ NH₃ as well as without H₂ and not treated with nitrogen-plasma (Co not pretreated with H₂ plasma)] electrodes. At the 100th cycle of potential cycling, the specific capacitance increased in the range from 700 to 750°C of CNT growing temperatures and then decreased in the range from 750 to 800°C. The reason behind this behavior may be that the average surface area density (see S2, S3, and S4 in Table 1) of the CNTs grown at 750°C is higher than those at 700 or 800°C, thus leading to higher capacitance at 750°C. This picture may be also explained why the CNTs grown at 750°C are more vertically aligned than those at 700 or 800°C (see Fig. 2), and that less surface contact between the CNTs, and consequently higher surface area is able to contribute to specific capacitance at 750°C. Furthermore, the specific capacitances for the electrode of the CNTs grown at 750 or 800°C increased with the cycle number, although, the specific capacitances for the electrode of the CNTs grown at 700°C decreased with the cycle number (see Fig. 1). Since the CNTs
Table 1. The CNT surface area density ($\pi \times$ CNT average diameter $\times$ CNT thickness $\times$ CNT packing density) and $I_c/I_D$ for Co (catalyst) not pretreated or pretreated with H$_2$ plasma and the CNTs grown at different conditions as well as not treated with nitrogen-plasma.

<table>
<thead>
<tr>
<th></th>
<th>CNT average diameter (nm)</th>
<th>CNT thickness (µm)</th>
<th>CNTs packing density (cm$^{-3}$)</th>
<th>CNT average surface area density (nm$^2$ cm$^{-2}$)</th>
<th>$I_c/I_D$</th>
</tr>
</thead>
<tbody>
<tr>
<td>S1: Co not pretreated with H$_2$ plasma and CNTs grown at 750°C, without NH$_3$, without H$_2$</td>
<td>34.0</td>
<td>5.50</td>
<td>$1.7 \times 10^{10}$</td>
<td>9.98 $\times 10^{15}$</td>
<td>0.851</td>
</tr>
<tr>
<td>S2: Co not pretreated with H$_2$ plasma and CNTs grown at 700°C, in 50 cm$^3$ min$^{-1}$ NH$_3$, without H$_2$</td>
<td>30.3</td>
<td>4.07</td>
<td>$2.3 \times 10^{10}$</td>
<td>8.90 $\times 10^{15}$</td>
<td>0.821</td>
</tr>
<tr>
<td>S3: Co not pretreated with H$_2$ plasma and CNTs grown at 750°C, in 50 cm$^3$ min$^{-1}$ NH$_3$, without H$_2$</td>
<td>32.3</td>
<td>6.09</td>
<td>$3.0 \times 10^{10}$</td>
<td>1.85 $\times 10^{16}$</td>
<td>0.919</td>
</tr>
<tr>
<td>S4: Co not pretreated with H$_2$ plasma and CNTs grown at 800°C, in 50 cm$^3$ min$^{-1}$ NH$_3$, without H$_2$</td>
<td>96.3</td>
<td>1.44</td>
<td>$2.7 \times 10^{10}$</td>
<td>1.17 $\times 10^{16}$</td>
<td>0.871</td>
</tr>
<tr>
<td>S5: Co pretreated with H$_2$ plasma and CNTs grown at 750°C, in 50 cm$^3$ min$^{-1}$ NH$_3$, without H$_2$</td>
<td>30.2</td>
<td>6.07</td>
<td>$4.1 \times 10^{10}$</td>
<td>2.35 $\times 10^{16}$</td>
<td>0.886</td>
</tr>
<tr>
<td>S6: Co pretreated with H$_2$ plasma and CNTs grown at 750°C, in 50 cm$^3$ min$^{-1}$ NH$_3$, in H$_2$</td>
<td>30.12</td>
<td>6.11</td>
<td>$4.3 \times 10^{10}$</td>
<td>2.48 $\times 10^{16}$</td>
<td>0.921</td>
</tr>
</tbody>
</table>

Figure 2. FE-SEM cross-section micrographs of CNTs grown in 50 cm$^3$ min$^{-1}$ NH$_3$ as well as without H$_2$ at different temperatures [(a): 700°C, (b): 750°C, and (c): 800°C] and not treated with nitrogen-plasma (Co not pretreated with H$_2$ plasma).
(catalyst) pretreated with H₂ plasma is always higher than that for Co (catalyst) not pretreated with H₂ plasma. The reason behind this behavior may be explained as follows. Co (catalyst) pretreated with H₂ plasma promotes the formation of Co nanoparticles (see Fig. 8) acting as the nucleation seeds for the growth of CNTs as well as reducing Co oxide from the catalytic surface—so keeping the Co (catalyst) active. Thus the average surface area density (see S3 and S5 in Table 1) for Co (catalyst) pretreated with H₂ plasma is higher than that for Co (catalyst) not pretreated with H₂ plasma, thus leading to higher capacitance for Co (catalyst) pretreated with H₂ plasma. Furthermore, the curve of the specific capacitance for Co (catalyst) pretreated with H₂ plasma is almost the same as that for Co (catalyst) not pretreated with H₂ plasma (see Fig. 7) since they have similar Raman spectroscopic characteristics (see S3 and S5 in Table 1 and Fig. 3).

Figure 9 shows the effects of the CNTs grown in H₂ as well as without H₂ and different charge-discharge cycles on the specific capacitances of the CNT [grown at 750°C in 50 cm³ min⁻¹ NH₃ and not treated with nitrogen-plasma (Co pretreated with H₂ plasma)]

**Figure 3.** The Raman spectra of CNTs for (a): S1, (b): S2, (c): S3, (d): S4, (e): S5, and (f): S6 in Table 1.

**Figure 4.** The effects of the CNTs grown in different NH₃ flow rates and different charge-discharge cycles on the specific capacitances of the CNT [grown at 750°C without H₂ and not treated with nitrogen-plasma (Co not pretreated with H₂ plasma)] electrodes.
Figure 5. FE-SEM cross-section micrographs of CNTs grown at 750°C in H₂ as well as (a) without NH₃ & (b) in 50 cm³ min⁻¹ NH₃ and treated with nitrogen-plasma (Co pretreated with H₂ plasma).

Figure 6. TEM morphologies of CNTs grown at 750°C without H₂ as well as (a) without NH₃ & (b) in 50 cm³ min⁻¹ NH₃ and not treated with nitrogen-plasma (Co not pretreated with H₂ plasma).

Figure 7. The effects of Co (catalyst) not pretreated as well as pretreated with H₂ plasma and different charge-discharge cycles on the specific capacitances of the CNT (grown at 750°C in 50 cm³ min⁻¹ NH₃ as well as without H₂ and not treated with nitrogen-plasma) electrodes.

Figure 8. FE-SEM micrographs of (a) Co (catalyst) not pretreated with H₂ plasma and (b) Co (catalyst) pretreated with H₂ plasma.

Figure 9. The effects of the CNTs grown in H₂ as well as without H₂ and different charge-discharge cycles on the specific capacitances of the CNT [grown at 750°C in 50 cm³ min⁻¹ NH₃ and not treated with nitrogen-plasma (Co pretreated with H₂ plasma)] electrodes.
The specific capacitance of the CNTs grown in H₂ is always higher than that without H₂. The reason behind this behavior may be that the average surface area density (see S5 and S6 in Table 1) of the CNTs grown in H₂ is higher than that without H₂, thus leading to higher capacitance. Furthermore, the curve of the specific capacitance of the CNTs grown in H₂ is almost the same as that without H₂ (see Fig. 9) since they have similar Raman spectroscopic characteristics (see S5 and S6 in Table 1 and Fig. 3).

A CV curve at a potential scan rate of 100 mV s⁻¹ in a 0.1 M H₂SO₄ solution for the CNT (S6 in Table 1 treated with nitrogen-plasma) electrode is shown in Fig. 10(a), which agrees with the CV curve reported for other CNT electrode.⁰²⁻²⁸ A CV curve at a potential scan rate of 100 mV s⁻¹ in a 0.5 M LiCl solution for the manganese-cobalt-zinc oxide/CNT (S6 in Table 1 treated with nitrogen-plasma) electrode is shown in Fig. 10(b), which shows redox peaks due to a Faradic process occurring in manganese-cobalt-zinc oxide.

Figure 11 shows the effects of the CNTs grown in 50 cm³ min⁻¹ NH₃ as well as without NH₃ and different charge-discharge cycles on the specific capacitances of the manganese-cobalt-zinc oxide/CNT (grown at 750°C in H₂ and treated with nitrogen-plasma (Co pretreated with H₂ plasma)) electrodes.

Figure 12. FE-SEM micrographs of the manganese-cobalt-zinc oxide/CNT (grown at 750°C in H₂, (a) without NH₃ as well as (b) in 50 cm³ min⁻¹ NH₃ and treated with nitrogen-plasma (Co pretreated with H₂ plasma)) electrode.

4. Conclusion

The specific capacitance of the CNT electrode for Co pretreated with H₂ plasma was higher than that for Co not pretreated with H₂ plasma and the specific capacitance of the CNT electrode for the CNTs grown in H₂ was higher than that without H₂. Furthermore, the specific capacitances for the electrode of the CNTs grown at 750 or 800°C increased with the cycle number, whereas, the specific capacitance for the electrode of the CNTs grown at 700°C decreased with the cycle number and the CNTs grown at 750°C were also more vertically aligned than those at 700 or 800°C. Moreover, the specific capacitance for the electrode of the CNTs grown in 50 cm³ min⁻¹ NH₃ increased with the cycle number, whereas, the specific capacitance for the electrode of the CNTs grown without NH₃ decreased with the cycle number and the CNTs grown in 50 cm³ min⁻¹ NH₃ were also more vertically aligned than those without NH₃.

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